

APPENDIX

Changes to Abstract:

The following is a marked-up version of the amended Abstract:

A method for manufacturing an organic EL device ~~comprising~~ in accordance with the invention includes: coating a composition including an organic EL material on a plurality of electrodes to form an organic EL layer on each electrode; defining an effectively optical area in which the plurality of electrodes are formed; and defining a coating area which is broader than the effectively optical area, on which the composition including an organic EL material is to be coated. According to this method, a uniform display device without uneven luminance and uneven chrominance within a pixel or among a plurality of pixels in the effectively optical area can be obtained.

Changes to Specification:

A Substitute Specification is attached in accordance with 37 C.F.R. 1.125(b)(2).

Changes to Claims:

The following are marked-up versions of the amended claims:

1. (Amended) A method for manufacturing an organic EL device, comprising:
coating a composition including an organic EL material above a plurality of electrodes to form an organic EL layer above each of the plurality of electrodes;
defining an effectively optical area in which the plurality of electrodes are formed; and
defining a coating area, ~~being~~ that is broader than the effectively optical area, in which the composition including ~~an~~ the organic EL material is to be coated.
2. (Amended) ~~A~~ The method according to claim 1, ~~wherein the defining a coating area step including defining the coating area includes to include~~ the perimeter of the effectively optical area.

3. (Amended) A- The method according to claim 1, wherein the defining a coating area step including defining the coating area located along the perimeter of the effectively optical area is to be a dummy area in which the composition including an the organic EL material is also coated to form an organic EL layer.

4. (Amended) A- The method according to claim 3, further comprising:
forming a layer made of the same material as that of the electrodes in the dummy area; and
coating the composition including an the organic EL material on the layer.

5. (Amended) A- The method according to claim 1, further comprising:
providing a group of effectively optical areas formed of a plurality of the effectively optical areas on a substrate; and
defining dummy areas around the effectively optical areas, respectively, and another dummy area encompassing the group of effectively optical areas.

6. (Amended) A- The method according to claim 3, wherein a process of further including starting the step of coating of the composition including an the organic EL material is started at the dummy area prior to coating on the effectively optical area and ends ending at the dummy area after coating on the effectively optical area.

7. (Amended) A- The method according to claim 1, wherein further including disposing individual areas to be coated in the entirety of the coating area are disposed at a constant pitch from each other.

8. (Amended) A- The method according to claim 7, wherein further including disposing any one of the electrodes is disposed relative to adjacent ones of the electrodes at a constant pitch.

9. (Amended) A method for manufacturing an organic EL device which includes an effectively optical area having a plurality of electrodes and an organic EL layer formed above each of the plurality of electrodes, the method comprising:

forming the organic EL layer both on areas that are to be the effectively optical area and on other areas that are not to be the effectively optical area.

10. (Amended) A method for manufacturing an organic EL device which includes an effectively optical area having a plurality of electrodes and an organic EL layer formed above each of the plurality of electrodes, the method comprising:

~~further~~ forming the organic EL layer in areas not having the electrodes and which are supposed to be the ~~optically active~~ effectively optical area.

11. (Amended) An organic EL device manufactured ~~using a~~ according to the method ~~according to~~ of claim 1.

12. (Amended) An organic EL device, ~~having comprising:~~
_____ a plurality of electrodes; ~~and~~
_____ an organic EL layer formed above each of the plurality of electrodes-
~~comprising:~~

an effectively optical area in which the plurality of electrodes are formed; and
a dummy area, that is disposed around the effectively optical area, in which the electrodes are also formed.

13. (Amended) ~~An~~ The organic EL device according to claim 12, further comprising a bank layer disposed between the plurality of electrodes, ~~wherein~~ the organic EL layer in the dummy area is being disposed on a layer made of ~~the a~~ same material as ~~that of~~ the bank layer.

14. (Amended) ~~An~~ The organic EL device according to claim 13, ~~wherein~~ the bank layer ~~includes including~~ an organic bank layer and an inorganic bank layer, and the

organic EL layer in the dummy area is being disposed on a layer made of ~~the a~~ same material as ~~that of~~ the inorganic bank layer.

15. (Amended) ~~An~~ The organic EL device according to claim 14, ~~wherein~~ the bank layer is being disposed laterally between portions of the organic EL layer in the dummy area.

16. (Amended) ~~An~~ The organic EL device according to claim 13, ~~wherein~~ the organic EL layer in the dummy area is being disposed on a layer made of ~~the a~~ same material as ~~that of~~ the organic bank layer.

17. (Amended) ~~An~~ The organic EL device according to claim 12, ~~wherein~~ the organic EL layer in the dummy area is being disposed on a layer made of ~~the a~~ same material as ~~that of~~ the electrodes.

18. (Amended) ~~An~~ The organic EL device according to claim 17, ~~wherein~~ the bank layer is being formed laterally between portions of the organic EL layer in the dummy area.

19. (Amended) ~~An~~ The organic EL device according to claim 12, ~~wherein~~ adjacent portions of the organic EL layer ~~are~~ being disposed at a constant pitch in both the effectively optical area and the dummy area.

20. (Amended) ~~An~~ The organic EL device according to claim 12, ~~wherein~~ both the effectively optical area and the dummy area ~~are~~ being provided on a substrate, and portions in the effectively optical area on the substrate ~~have~~ having a substantially ~~the~~ same cross-sectional structure as ~~that of~~ portions in the dummy area on the substrate.

21. (Amended) An organic EL device, including comprising:
_____ an effectively optical area having a plurality of electrodes and an organic EL layer formed on each of the plurality of electrodes, ~~wherein~~ the organic EL layer is being

formed both on areas supposed to be the effectively optical area and on other areas not supposed to be the effectively optical area.

22. (Amended) An organic EL device, ~~including comprising~~:
_____an effectively optical area having a plurality of electrodes and an organic EL layer formed above each of the electrodes, ~~wherein the organic EL layer is also being~~ formed in areas not having the electrodes and which are supposed to be the effectively optical area.

23. (Twice Amended) An electronic device, comprising:
_____~~an the~~ organic EL device according to claim 12.